



Docket No.: M4065.0278/P278

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Kevin L. Beaman, et al.

Application No.: 09/653,281

Filed: August 31, 2000

For: USE OF ATOMIC OXIDATION FOR

FABRICATION OF OXIDE-NITRIDE-OXIDE STACK FOR FLASH MEMORY

DEVICES

Group Art Unit: 2812

Examiner: Richard A. Booth

Mail Stop: Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22312-1450

Dear Sir:

This paper is in response to the Office Action dated March 21, 2003, please der the application in light of the following remarks. reconsider the application in light of the following remarks.